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RULE				
APPLICANTS Hideki Yamanaka, Fukushima, JAPAN; Kiyoshi Demizu, Tokyo, JAPAN; Tadahiro Ohmi, Miyagi, JAPAN; Akinobu Teramoto, Miyagi, JAPAN; Shigetoshi Sugawa, Miyagi, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP04/00869 01/29/2004				
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** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/DOUGLAS M MENZ/</u> Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 9	TOTAL CLAIMS 9
			INDEPENDENT CLAIMS 2	
ADDRESS RADER FISHMAN & GRAUER PLLC LION BUILDING 1233 20TH STREET N.W., SUITE 501 WASHINGTON, DC 20036 UNITED STATES				
TITLE Silicon semiconductor substrate and its manufacturing method				
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	